

Notice of References Cited

Application/Control No.

10/538,534

Applicant(s)/Patent Under
Reexamination
FRASCH ET AL.

Examiner

Amanda M. Shaw

Art Unit

1634

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Sonnichsen, C et al. Drastic Reduction of Plasmon Damping in Gold Nanorods. 2002. Physical Review Letters. Vol 88. No 7 pages 1-4.
	V	Mock, JJ et al. Composite Plasmon Resonant Nanowires. 2002. Nano Letters. Vol 2 No 5. pages 465-469.
	W	
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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